FP-8050 series Spectrofluorometer

Contents

- 1. Lineup of FP-8050
- 2. Concepts and advantages
- 3. Introduction of each model
- 4. Accessories

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Lineup of FP-8050



FP-8250

Entry model

FP-8350

Standard model



FP-8550

Flagship model

FP-8650

Dedicated model for NIR FL

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Concepts



Advantages

<u>Supreme</u>

- Outstanding sensitivity
- Evolved high-order light cut-off filter
- Accurate spectrum correction

Smart

- ◆ Improved operability
- ◆ Support functions
- ◆ IQ accessory

Support

- ◆ Daily check
- ◆ Device usage record
- ◆ Long-life Xe lamp

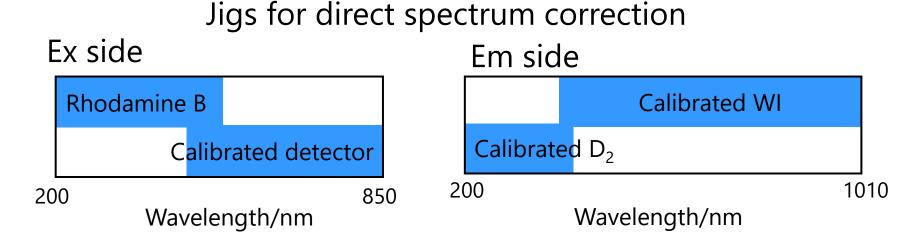
Outstanding sensitivity

High throughput optical system and low noise signal processing provide users with outstanding sensitivity.

Model	RMS		
FP-8250	4,500:1		
	(bandwidth (Ex, Em): 5 nm)		
ED 03E0	8,000:1		
FP-8350	(bandwidth (Ex, Em): 5 nm)		
ED OFFO	8,500:1		
FP-8550	((bandwidth (Ex, Em): 5 nm)		
FP-8650	3,500:1		
	(bandwidth (Ex): 5 nm, bandwidth (Em): 10 nm)		

Accurate spectrum correction

- Correction curve of whole range can be made directly
 - Ex side: Rhodamine B and Calibrated detector
 - Em side: Calibrated light source (WI and D₂)
- Direct correction can be executed even when integrating sphere is equipped.

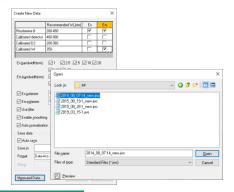


However, operation has been complicated and knowledge of spectrofluorometer has been required, so far.

Now, Correction curve can be made easily

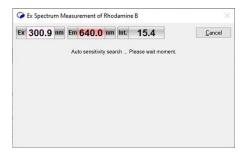
Step 1

Open the measured spectrum.



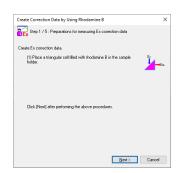
Step 4

Sensitivity is automatically searched.



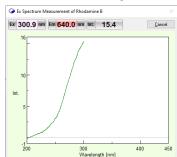
Step 2

Setting jigs.



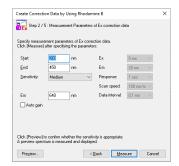
Step 5

Measurement is automatically started.



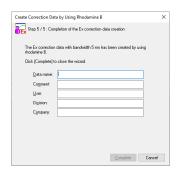
Step 3

Suitable parameters are auto set.



Step 6

Save the correction curve



Correction curve is easily gotten and no mistakes!

Advantages

<u>Supreme</u>

- Outstanding sensitivity
- ◆ Evolved high-order light cut-off filter
- ◆ Accurate spectrum correction

<u>Smart</u>

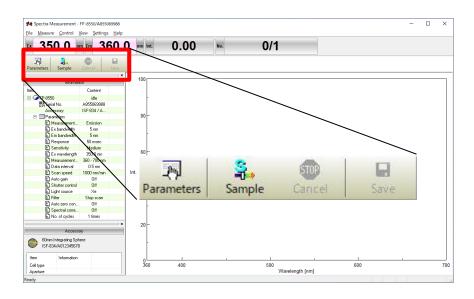
- Improved operability
- Support functions
- ◆ IQ accessory

Support

- ◆ Daily check
- ◆ Device usage record
- ◆ Long-life Xe lamp

Improved operability

- Auto Ex and Em shutter
- Self-motion "Auto zero"
- Sophisticated tool buttons



Step 1

Sample setting



Step 3

Measurement



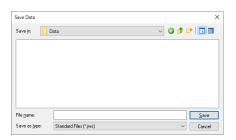
Step 2

Parameter setting



Step 4

Save data



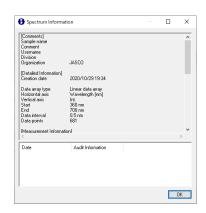
Support functions

Video manual

It explains how to maintain the instrument (lamp replacement, etc.) by the movie.



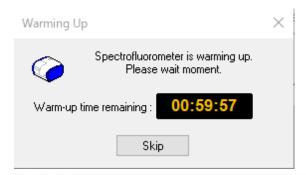
Saturation log (photometric value)



When photometric value exceeds the measurement limit during measurement, its saturation information is recorded as log.

Standby timer

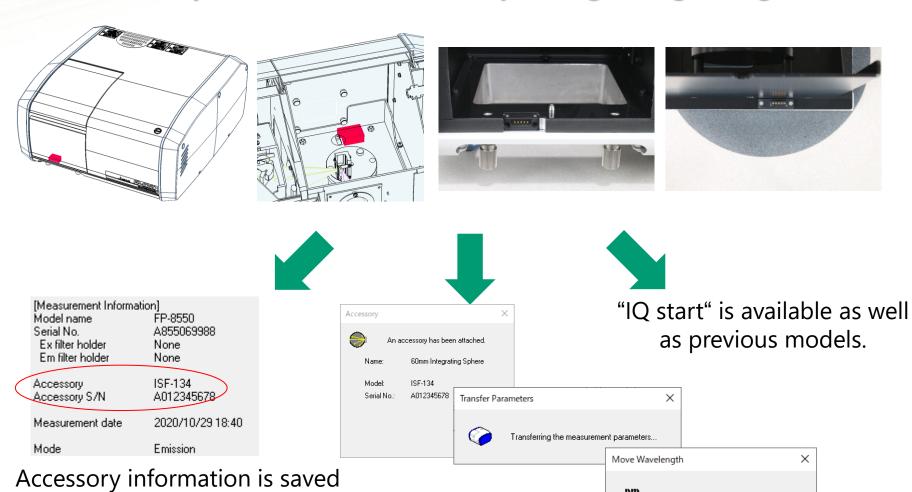
It displays the remaining time of warm-up.



IQ accessory

in measurement data

Easy and robust accessory recognizing design



JASCO

Moving to specified wavelength...

Advantages

<u>Supreme</u>

- Outstanding sensitivity
- ◆ Evolved high-order light cut-off filter
- ◆ Accurate spectrum correction

Smart

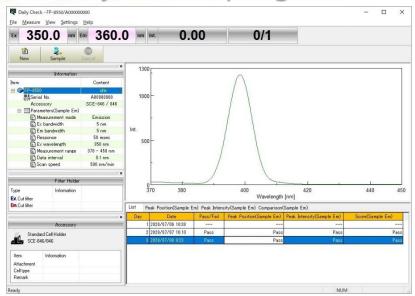
- ◆ Improved operability
- ◆ Support functions
- ◆ IQ accessory

<u>Support</u>

- Daily check
- Device usage record
- ◆ Long-life Xe lamp

Daily monitoring of instrument conditions

[Daily check] program



List Peak Position(Sample Em) Peak Intensity(Sample Em) Comparison(Sample Em)					
Day	Date	Pass/Fail	Peak Position(Sample Em)	Peak Intensity(Sample Em)	Score(Sample Em)
	1 2020/07/06 10:38	1000	N ame		
	2 2020/07/07 16:10	Pass	Pass	Pass	Pass
	3 2020/07/08 9:23	Pass	Pass	Pass	Pass

- Inspection jig: diffusion plate (Xe lamp) or standard sample
- Inspection item: peak position, peak intensity, spectrum comparison
- Batch display of measured data in time series

Inspection procedure

Step 1 Runs the program.

Step 2 Sets the sample

Step 3 Starts the inspection

Step 4 Displays the result within X minutes

Step 5 Closes the program

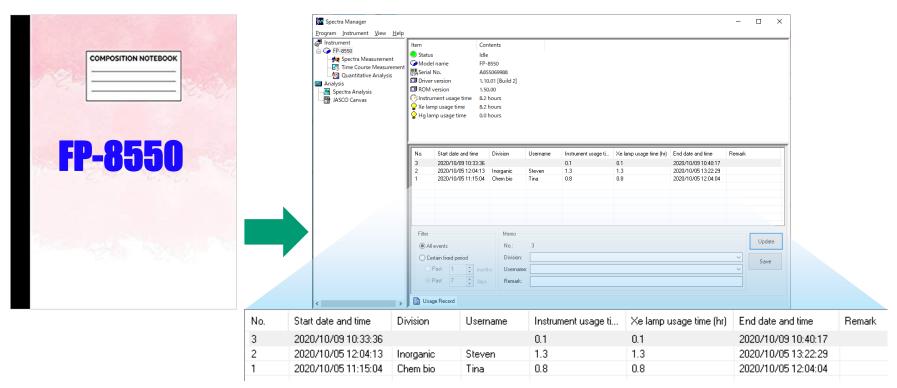
It enables to perform daily instrument performance verification without feeling stress.

- Quick performance check
- Comparison with previous instrument performance

etc.

Auto-recording function of instrument activity log

It records the usage status of multi user, lamp usage time, etc.



It can be used as the instrument log books which work in shared instrument facility. Actually, date and time information, and instrument and Xe lamp usage information is automatically recorded. Username can be added one by one.



Long-life Xe lamp

Maximum usage time of new Xe lamp: 3000 hours Product guarantee: 1000 hours or a year

service cost reduction and cost efficiency

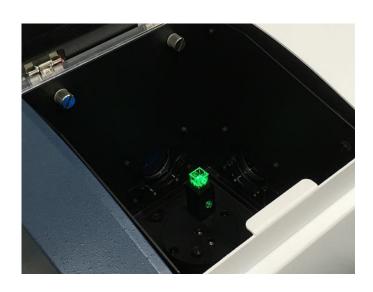
Brand	JASCO	Hitachi	Shimadzu
Model	FP-8050	F-7100	RF-6000
Max. usage time	3000 hours	2500 hours	2000 hours
Guarantee	1000 hours or A year	500 hours or 6 months	Not disclosed

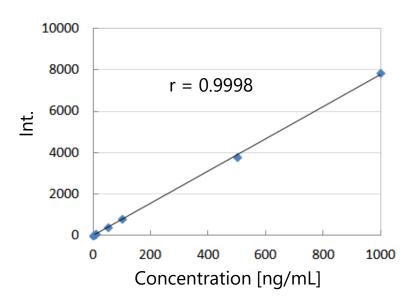
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Entry model

- Liquid sample measurement
- Quantitative analysis
 - * Evolved high-order light cut-off filter is not available for this model.



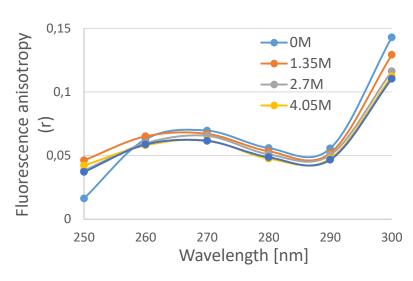


Measurement using of one drop accessory (PicogreenTM labeled λ DNA)

Standard model

- Outstanding sensitivity
- Evolved high-order light cut-off filter is mounted as standard.
- Various life science applications

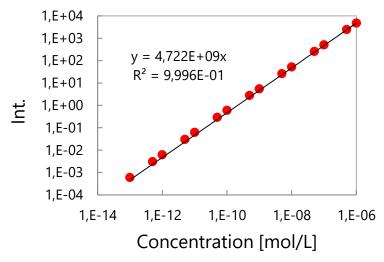




Fluorescence anisotropy excited discrete spectrum Apo- α -lactalbumin + GuHCl

Flagship model

- Outstanding sensitivity (RMS:8,500:1)
- Wavelength extension detector is equipped as standard (200-850 nm range)
- Various applications for solid and liquid samples









FP-8650

Dedicated model for NIR region measurement

- High performance using of NIR high sensitivity PMT
- Conventional detector can be selected as option.

	FP-8600	FP-8650
Phosphorescence measurement	N.A.	Available
Wavelength region	200-1010 nm	200-980 nm



Specification (1)

	FP-8250	FP-8350	FP-8550	FP-8650	
Light source	150 W xenon lamp (long-life type, lifetime: 3,000h(estimate)) Low pressure Hg lamp (for validation)				
Photometric system	Photometric ratio system				
Monochromator	Modified Rowland mount with grating	n 1650 lines/mm concave	Modified Rowland mount with 1800 lines/mm concave grating	Modified Rowland mount with 1800 lines/mm concave grating (Ex monochromator), with 900 lines/mm concave grating (Em monochromator)	
	N/A	Higher-order diffraction light	cut-off filter		
Detector	Silicon photodiode (for Ex monochromator), Photomultiplier (for Em monochromator)				
Wavelength range	200–750 nm	200–750 nm (200–900 nm, with optional detector)	200–850 nm	Ex: 200–850 nm Em: 200–980 nm (200– 1010 nm, with optional detector)	
Spectral bandwidth	1, 2.5, 5, 10, 20 nm		1, 2.5, 5, 10, 20, L5, L10 nm	Ex: 1, 2.5, 5, 10, 20, L5, L10 nm Em: 2, 5, 10, 20, 40, L10, L20 nm	
Wavelength accuracy	± 1.5 nm		± 1.0 nm (± 0.3 nm at 546.1 nm)	Ex:± 1.0 nm (± 0.3 nm at 546.1 nm) Em: ± 2.0 nm (± 0.3 nm at 546.1 nm)	
Wavelength repeatability	± 1.0 nm		± 0.3 nm		
Wavelength slew speed	30000 nm/min		60000 nm/min	Ex: 60000 nm/min Em: 120000 nm/min	
Wavelength scanning speed	20000 nm/min		60000 nm/min	Ex: 60000 nm/min Em: 120000 nm/min	



Specification (2)

	FP-8250	FP-8350	FP-8550	FP-8650	
Compitinity	4,500:1	8,000:1	8,500:1	3,500:1	
Sensitivity (RMS)	Bandwidth: Ex 5 nm, Em 5 nm			Bandwidth: Ex 5 nm, Em 10 nm	
Photomultiplier voltage	High, Medium, Low, Very Low, Auto, Manual (0-1000 V)				
1 Hotomulipher voltage	With automatic gain control				
Resolution	1.0 nm (546.1 nm)			Ex 1.0 nm	
resolution	1.0 1111 (340.1 11111)			Em 2.0 nm	
Photometric display	-10000–10000				
Nitrogen purge	Available				
Dimension	520 (W) x 545 (D) x 270 (H)	520 (W) x 545 (D) x 270 (H)	570 (W) x 545 (D) x 270 (H)	570 (W) x 545 (D) x 270 (H)	
Dimension	mm	mm	mm	mm	
Weight	36 kg	36 kg	39 kg	39 kg	



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Various accessories

- FP-8000-like lineup
- FP-8000 series' accessories can be also used (manual).

New accessories are shown below.

*Lead time of highlighted accessories will be 3 months in general.

CTH-107	Water thermostatted cell block	OBF-132	Optical fiber unit
STR-112	Water thermostatted cell holder with stirrer	EFA-133	Epi-Fluorescence Unit
EHC-113	Air-cooled Peltier thermostatted cell holder with stirrer	ISF-134	60 mm dia. Integrating Sphere
ETC-115	Water-cooled peltier thermostatted cell holder with stirrer	ILF-135	120 mm dia. Integrating Sphere
FCT-117	Water thermostatted automatic 8-position turret cell changer	HPC-136	High temperature powder cell unit
FCT-117S	Water thermostatted automatic 8-position turret cell changer with stirrer	ESC-142	Calibrated light source (WI)
PCT-118	Water-cooled peltier thermostatted 4-position automatic cell changer with stirrer		
SHP-120	Peristaltic Sipper	ESC-143	Calibrated light source (D ₂)
QFS-122	Vacuum Sipper	SID-144	Calibrated detector
FSC-124	Micro flow cell holder	SCE-146	Standard Cell Holder
FMP-125	Microplate reader	ILFC-147	Cooled 120 mm dia. integrating sphere
ATS-127	Automatic titration unit	SAF-151	One drop accessory
CSP-129	Sample compartment lid with syringe port	CTS-155	Coumarin measurement unit
PMU-130	Liquid nitrogen cooling unit	FMD-160	Cell holder for high-speed scanning
CSH-131	Cryostat holder		

